



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

U.S. Serial No. 10/743,629

Applicant: Ki Min LEE

Filed: December 22, 2003

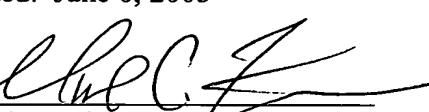
Title: "Methods of Preventing  
Oxidation of Barrier Metal of  
Semiconductor Devices"

TC/AU: 2818

Examiner: NHU, David

Docket No.: 20063/OG03-040

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Commissioner for Patents  
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**RESPONSE TO THE OFFICE ACTION DATED MARCH 3, 2005**

Dear Sir:

Please enter the following amendments and consider the following remarks.

**Changes to the Specification** begin on page 2 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 3 of this paper.

**Remarks** begin on page 5 of this paper.